

Image



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Koichi HASHIMOTO et al

Serial Number: 10/028,429

Filed: December 28, 2001

For: DRY ETCHING WITH REDUCED DAMAGE
TO MOS DEVICE

Confirmation No.: **4380**

Group Art Unit: 2823

Examiner: K. Nguyen

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

March 15, 2004

Sir:

Please amend the subject application as follows: